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CONFIRMATION NO. 4943

<b>SERIAL NUMBER</b> 10/518,945	<b>FILING OR 371(c) DATE</b> 07/13/2005 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2893	<b>ATTORNEY DOCKET NO.</b> 36856.1310
<b>APPLICANTS</b> Yoshihiro Ito, Nagaokakyo-shi, JAPAN; Michio Kadota, Kyoto, JAPAN;  <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/07055 06/04/2003  <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-172301 06/13/2002				
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged _____ Examiner's Signature _____ Initials _____		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 7	<b>TOTAL CLAIMS</b> 19
				<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> 54066				
<b>TITLE</b> SEMICONDUCTOR DEVICE IN WHICH ZINC OXIDE IS USED AS A SIMICONDUCTOR MATERIAL AND METHOD FOR MANUFACTURING THE SEMICONDUCTOR DEVICE				
<b>FILING FEE RECEIVED</b> 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	